


<b>Search Notes</b>  	<b>Application/Control No.</b>  10626340	<b>Applicant(s)/Patent Under Reexamination</b>  CHU ET AL.
	<b>Examiner</b>  Lovel, Kimberly	<b>Art Unit</b>  2167

SEARCHED			
Class	Subclass	Date	Examiner
707	999.101; 809 with keywords	3/13/2010	KL
715	237 with keywords	3/13/2010	KL

SEARCH NOTES		
Search Notes	Date	Examiner
East - see attached	1/2/2009	KL
Google with keywords (validating parser, abstraction level, base schema, extended schema)	1/2/2009	KL
Updated Search - see attached	6/20/2009	KL
East - see attached	3/13/2010	KL
Inventor search - see attached East Search	3/13/2010	KL
NPL (ACM) with keywords (abstraction level/casting, validating parser) - see attached	3/13/2010	KL
NPL(Google) with keywords (abstraction level/casting, validating parser) - see attached	3/13/2010	KL
Consulted with and concurred allowable subject matter with Kuen Lu (Primary Examiner, 2156)	3/10/2010	KL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
707	999.101 and 809 with claim text	3/13/2010	KL
715	237 with claim text	3/13/2010	KL

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